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EXAMINER'S AMENDMENT

1. An examiner's amendment to the record appears below. Should the changes and/or additions be unacceptable to applicant, an amendment may be filed as provided by 37 CFR 1.312. To ensure consideration of such an amendment, it MUST be submitted no later than the payment of the issue fee.

Authorization for this examiner's amendment was given in a telephone interview with Mrs. Anna-lisa L. Gallo on May 19, 2011.

The application has been amended as follows:

In claim 15, line 12, delete "of layers" and insert - - of the resist layer - - in its place.

The claims 26-29 are cancelled.

2. The following is an examiner's statement of reasons for allowance:

Ichimura et al. (US Patent 5,246,815) do not teach a method of making a base material for screen printing as instantly claimed, wherein the resist layer has a roughness Rz of less than 15 micrometers on the side of the protective film.

There are no prior art teachings that would motivate one of ordinary skill in the art at the time of the invention to modify Ichimura et al. and obtain the method of claim 15 of the instant application.

Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably

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accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."

Any inquiry concerning this communication or earlier communications from the examiner should be directed to ANCA EOFF whose telephone number is (571)272-9810. The examiner can normally be reached on Monday-Thursday, 6:30 AM-4:00 PM, EST and Friday, 6:30-10:30 AM, EST.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Cynthia H. Kelly can be reached on 571-272-1526. The fax phone number for the organization where this application or proceeding is assigned is 571-273-8300.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free). If you would like assistance from a USPTO Customer Service Representative or access to the automated information system, call 800-786-9199 (IN USA OR CANADA) or 571-272-1000.

/A. E./ Examiner, Art Unit 1722

/Cynthia H Kelly/ Supervisory Patent Examiner, Art Unit 1722